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Please Direct All Correspondence to Customer Number 20995

AMENDMENT / RESPONSE TRANSMITTAL

Applicant

HYODO, et al.

App. No

10/644,195

Filed

August 20, 2003

For

METHOD OF FORMING SILICON-

CONTAINING INSULATION FILM

HAVING LOW DIELECTRIC CONSTANT AND LOW FILM

STRESS

Examiner

David S. Blum

Art Unit

2813

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

(X) Amendment in six (6) pages.

The fee has been calculated as shown below:

FEE CALCULATION								
FEE TYPE						FEE CODE	CALCULATION	TOTAL
Excess Claims	14	-	24	=	0	1202 (\$50)	0 x 50 =	\$0
Excess Independent	1	-	3	=	0	1201 (\$200)	0 x 200 =	\$0
1 Month Extension	1.17(a)(1)					1251 (\$120)		\$120
							TOTAL FEE DUE	\$120

- (X) An extension of time is hereby requested by payment of the appropriate fee indicated above.
- (X) Charge \$120 to Deposit Account No. 11-1410.

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(X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Katsuhiro Arai Registration No. 43,315 Attorney of Record Customer No. 20,995 (949) 760-0404

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